

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L5	40	(wafer near etch\$3) same (metal near mask\$3)	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:28
L6	8	(etch\$3 same silicon) same (metal near (mask \$3 with aluminum))	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:38
L7	1343	(coil with (substrate or wafer)) same distance	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:51
L8	205	7 same induct\$3	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:52
L9	69	8 and @pd<"20020814"	US_PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/04/05 11:52

4/ 5 / 08 1:06:58 PM

C:\ Documents and Settings\SAhmed2\My Documents\EAST\Workspaces\10524525.wsp